



IEW 2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: **Aberle et al.**)
)
Appln. No.: **10/530,848**)
)
Filed: **April 8, 2005**)
)
For: **FABRICATION METHOD)
FOR CRYSTALLINE)
SEMICONDUCTOR FILMS)
ON FOREIGN)
SUBSTRATES)**
)
Group)
Art Unit: **2812**)
)
Examiner: **Not Yet Assigned**)
)
Docket No.: **85267**)
)
Cust. No.: **22242**)

Conf. No.: **2457**

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

3/14/06
Date

L. Saf.
Lilia I. Safonov
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STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The above-identified application was filed with the United States Patent and Trademark Office on April 14, 2005. We have not received the return post card with the Serial No., or any communication from the Patent and Trademark Office indicating action on this application. Kindly advise the undersigned of the present status of this application.

Respectfully submitted,

FITCH, EVEN, TABIN & FLANNERY

Date:

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